

IN THE SPECIFICATION

Please replace the paragraphs [0027], [0029], [0030], and [0031] on page 4 with the following rewritten paragraphs:

G1
[0028] Figure 21 is a cross-sectional view of the material of Figure 17 or Figure 20 with the thin material of Figure 18 aligned thereto and positioned thereon such that the top of the post 26 is positioned and fixed within the slot 56;--

[0029] Figure 23 is a cross-sectional view of the material of Figure 22 after removal of the photoresist 52 and after wirebonding;

[0030] Figure 24 is a cross-sectional view of another embodiment of the mirror of the present invention;

[0031] Figure 25 is a cross-sectional view of yet another embodiment of the mirror of the present invention; --

IN THE CLAIMS

14. (Once Amended) A moveable micromirror for selectively directing optical beams, the micromirror comprising:

G2
a substrate formed of a first single crystal of silicon;

a post extending from within a moat in a surface of the substrate, the post being formed of the single crystal of silicon;

a table fixed along a plane generally perpendicular to and supported by the post and having a reflective surface facing away from the surface of the substrate and a second surface facing the surface of